

Docket No. 219289US90PCT

IN RE APPLICATION OF: Yasutaka ITO et al

SERIAL NO: 10/069,943

FILED: July 10, 2002

FOR: CARBON-CONTAINING ALUMINUM NITRIDE SINTERED COMPACT AND CERAMIC SUBSTRATE FOR USE IN EQUIPMENT FOR MANUFACTURING OR INSPECTING SEMICONDUCTOR



COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

Transmitted herewith is an Amendment in the above-identified application.

☒ No additional fee is required

☐ Small entity status of this application under 37 C.F.R. §1.9 and §1.27 is claimed.

☒ Additional documents filed herewith: Request for Extension of Time (three month); Copy of Form PTO-1449 Filed 01/15/03 (Attachment to Amendment)

The Fee has been calculated as shown below:

CLAIMS	CLAIMS REMAINING		HIGHEST NUMBER PREVIOUSLY PAID	NO. EXTRA CLAIMS	RATE	CALCULATIONS
TOTAL	16	MINUS	28	0	x \$18 =	\$0.00
INDEPENDENT	2	MINUS	5	0	x \$86 =	\$0.00
		<input type="checkbox"/> MULTIPLE DEPENDENT CLAIMS			+ \$290 =	\$0.00
		TOTAL OF ABOVE CALCULATIONS				\$0.00
		<input type="checkbox"/> Reduction by 50% for filing by Small Entity				\$0.00
		<input type="checkbox"/> Recordation of Assignment			+ \$40 =	\$0.00
		TOTAL				\$0.00

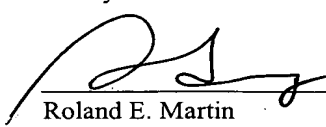
☐ A check in the amount of **\$0.00** is attached.

☒ Credit card payment form is attached to cover the fees in the amount of **\$950.00**

☒ Please charge any additional Fees for the papers being filed herewith and for which no check or credit card payment is enclosed herewith, or credit any overpayment to deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

☒ If these papers are not considered timely filed by the Patent and Trademark Office, then a petition is hereby made under 37 C.F.R. §1.136, and any additional fees required under 37 C.F.R. §1.136 for any necessary extension of time may be charged to Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

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IFW
DOCKET NO.: 219289US90PCT



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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF :

Yasutaka ITO et al

: GROUP ART UNIT: 1755

SERIAL NO.: 10/069,943

: EXAMINER: Karl E. GROUP

FILED: July 10, 2002 :

FOR: CARBON-CONTAINING ALUMINUM NITRIDE
SINTERED COMPACT AND CERAMIC SUBSTRATE
FOR USE IN EQUIPMENT FOR MANUFACTURING
OR INSPECTING SEMICONDUCTOR

AMENDMENT

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

This is in response to the Official Action mailed November 7, 2003.

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on
page 3 of this paper.

Remarks/Arguments begin on page 7 of this paper.